

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : Jiro KONDO, et al.  
Serial No. : 10/591,093  
Filed : August 29, 2006  
For : METHOD FOR REMOVING BORON FROM SILICON  
Examiner : Cohen, Stefanie J.  
Art Unit : 1732  
Confirmation No. : 7884

**Mail Stop AMENDMENT**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

I hereby certify this correspondence is being electronically transmitted to the United States Patent and Trademark Office via the Office electronic filing system on **April 12, 2011**

Signature: /Katy Chan-Parsons/  
Katy Chan-Parsons

**AMENDMENT**

In response to the Office Action dated January 20, 2011, Applicants respectfully request entry of the following amendments and comments into the file of the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.